

## SECTION II—CLAIMS

1. (Previously Presented) An apparatus comprising:
  - a die mounted on a substrate, the die being connected to the substrate by a plurality of wires; and
  - a mold cap encapsulating the die and the plurality of wires, the mold cap comprising an electrically insulating portion encapsulating substantially all the wires and the entire die, and a thermally conductive portion encapsulating substantially all the electrically insulating portion.
2. (Original) The apparatus of claim 1 wherein the die comprises an integrated circuit.
3. (Original) The apparatus of claim 1 wherein the electrically insulating material comprises a curable resin, a crosslinker, a catalyst, and a reinforcing filler.
4. (Original) The apparatus of claim 3 wherein the reinforcing filler comprises silica, alumina, zinc oxide, talc, or combinations thereof.
5. (Original) The apparatus of claim 1 wherein the thermally conductive material comprises a curable resin, a crosslinker, a catalyst, and a metal filler.
6. (Original) The apparatus of claim 5 wherein the metal filler comprises aluminum, silver, copper, gold, or combinations or alloys thereof.
- 7.-8. (Canceled)
9. (Original) The apparatus of claim 1, further comprising a heat dissipation device attached to, and in thermal contact with, the thermally conductive material.
10. (Previously Presented) An apparatus comprising:

a stack of dies mounted on a substrate, the stack including a first die attached to the substrate and at least one additional die stacked thereon;

a plurality of wires connecting at least one of the stacked dies to the substrate or to another die in the stack; and

a mold cap encapsulating the wires and the stacked dies, the mold cap comprising an electrically insulating portion encapsulating substantially all of the wires and the entire stack of dies, and a thermally conductive portion encapsulating substantially all the electrically insulating portion.

11. (Original) The apparatus of claim 10 wherein at least one of the stacked dies comprises an integrated circuit.
12. (Original) The apparatus of claim 10 wherein the first die is flip-chip bonded to the substrate.
13. (Original) The apparatus of claim 10 wherein the electrically insulating material comprises a curable resin, a crosslinker, a catalyst, and a reinforcing filler.
14. (Original) The apparatus of claim 10 wherein the reinforcing filler comprises silica, alumina, zinc oxide, talc, or combinations thereof.
15. (Original) The apparatus of claim 10 wherein the resin comprises a curable resin, a crosslinker, a catalyst, and a metal filler.
16. (Original) The apparatus of claim 15 wherein the metal filler comprises aluminum, silver, copper, gold, or combinations or alloys thereof.
- 17.-18. (Canceled)

19. (Original) The apparatus of claim 10, further comprising a heat dissipation device attached to, and in thermal contact with, the thermally conductive material.

20.-37. (Canceled)

38.-51. (Canceled)